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Dated: September 27, 2005 Signature:

(Gregory E. Stanton)

Docket No.: 29936/39463  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Si B. Kim

Application No.: 10/616,722

Confirmation No.: 2678

Filed: July 10, 2003

Art Unit: 2812

For: METHOD OF FORMING A COPPER WIRING  
IN A SEMICONDUCTOR DEVICE

Jennifer M. Kennedy

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated July 27, 2005, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.